



Docket No.: YIELD-0002 #11

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Bradley Dale Mitchell

RECEIVED

SERIAL NO.: 09/943,569

MAY 03 2004

FILING DATE: August 30, 2001

OFFICE OF PETITIONS

TITLE: System and Method for Removing Deposited Material from Within a Semiconductor Fabrication Device

EXAMINER: Alexander Markoff

ART UNIT: 1746

CERTIFICATE OF MAILING

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date printed below:

Date:

3/11/04

Name:

Beatrice Orozco
Beatrice Orozco

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REVOCATION OF ATTORNEY AND POWER OF ATTORNEY

The undersigned hereby revokes all powers of attorney previously given and hereby appoints David B. Ritchie, Registration No. 31,562; Robert E. Krebs, Registration No. 25,885; Marc S. Hanish, Registration No. 42,626; John P. Schaub, Registration No. 42,125; Adrienne Yeung, Registration No. 44,000; Steven J. Robbins, Registration No. 40,299; Thierry K. Lo, Registration No. 49,097; William Samuel Niece, Registration No.: 47,824; Kalhed Shami Registration No. 38,745; William E. Winters, Registration No. 42,232, Masako Ando, (37 C.F.R. §10.9 (b)); John Klaas Uilkema, Registration No. 20,282; Becky L. Troutman, Registration No. 36,703; and Hal J. Bohner, Registration No. 27,856, to act on applicant's behalf

03/10/04 WED 14:38 FAX 97234 04 . .
03-08-04 05:17pm From:Thelen, Reid, & Priest LLP

Brad Mitchell

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T-015 P.005/005 F-332

Docket No.: YIELD-0002

before the United States Patent and Trademark Office for the above-identified application and to transact all business in the Patent and Trademark Office in connection therewith.

Please mail all correspondence to the following address:

David B. Ritchie
THELEN REID & PRIEST LLP
P.O. BOX 640640
SAN JOSE, CA 95164-0640

and direct all telephone calls to David B. Ritchie at (408) 292-5800.

Respectfully submitted,

Dated: MARCH 10, 2004

Bradley D. Mitchell
Bradley D. Mitchell



Docket No.: YIELD-0002

#12

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Beatrice Orozco

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

**CHANGE OF ATTORNEY DOCKET NUMBER
AND CHANGE OF ADDRESS NOTICE**

Please change the Attorney Docket No. for this patent application from

012522:00012-1C to **YIELD-0002**

Please address all further communications regarding this application to:

David B. Ritchie
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Respectfully submitted,
THELEN REID & PRIEST LLP

Dated: March 10, 2004

David B. Ritchie
Reg. No. 31,562